



JAN/AF

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

: Confirmation No. 6339

Kazufumi SATO et al.

: Docket No. 2003_1687

Serial No. 10/716,632

: Group Art Unit 1752

Filed November 20, 2003

: Examiner Yvette C. Thornton

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RESPONSE TO FINAL REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Rejection dated February 9, 2005, please amend the present application as follows: